



PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

August 16, 2005

Applicant: Toru IMORI et al

Title: METAL PLATING METHOD, PRETREATMENT AGENT, AND
SEMICONDUCTOR WAFER AND SEMICONDUCTOR DEVICE
OBTAINED USING THESE

Serial No.: 10/767 697

Group: 2822

Confirmation No.: 5592

Filed: January 29, 2004

Examiner: Novacek

Atty. Docket No.: Komatsu 267A

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Herewith is an amendment in the above-identified application.

☐ Applicant claims small entity status. See 37 CFR 1.27.☐ The additional filing fee has been calculated as shown below:

For	No. Filed	No. Extra	(X) LG Entity	RATE	() SM Entity	Fee
Total Claims	(11 - 20 = 0)		x	\$ 50.00	x	\$ 25.00
Indep. Claims	(2 - 3 = 0)		x	\$200.00	x	\$100.00
[] Multiple Dep. Claim			+	\$360.00	+	\$180.00
* * * TOTAL FILING FEE * * *						\$ 0.00

☐ Pursuant to 37 CFR 1.136(a), please extend the shortened period for response by month(s). The extension fee is: \$.☐ A Check for \$ is enclosed to cover fees.☒ Please credit any overpayment, or charge any additional filing fee required under 37 CFR 1.16 or 1.17 by this communication, to Deposit Account No. 06-1382. A duplicate copy of this sheet is enclosed.

IN DUPLICATE

TFC/smd

Terryence F. Chapman Reg. No. 32 549

CERTIFICATE OF MAILING

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130.12/04

Terryence F. Chapman



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Alexandria, VA 22313-1450

RESPONSE


Sir:

In response to the Office Action dated May 19, 2005,
please amend the above-identified application as follows:

(Please see following pages.)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
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Alexandria, VA 22313-1450, on August 16, 2005.


Terryence F. Chapman